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Notice of Allowability	Application No.	Applicant(s)
	10/014,527	BERKSTRESSER ET AL.
	Examiner	Art Unit
	Anthony Ojini	3723
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. X This communication is responsive to <u>amendment after final filed_8/27/04</u> .		
2. ☑ The allowed claim(s) is/are <u>1-9 and 11-21</u> .		
3. 🗵 The drawings filed on <u>06 February 2002</u> are accepted by the Examiner.		
4.		
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 12/14/01 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview Summary Paper No./Mail Dat 7. ☐ Examiner's Amenda 8. ☑ Examiner's Stateme 9. ☐ Other	e

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REASON FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance: the art of record considered as a whole or in combination, neither anticipates nor renders obvious a rigid plate assembly being receivable on a rotatable plate in a CMP machine, comprising a rigid plate member having a top surface, a bottom surface and self-alignment structures disposed thereon used to self align the rigid plate assembly receivable on the rotatable plate in combination as claimed in claims 1,3; and a method to use a vacuum to old a rigid plate assembly to a rotatable platen in a polishing apparatus, comprising a step of suctioning the rigid plate assembly onto a top surface of the rotatable platen wherein the rigid assembly automatically aligns with respect to the rotatable platen upon suctioning the rigid platen onto the rotatable platen in combination as claimed in claim 13.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Anthony Ojini whose telephone number is 703 305 3768. The examiner can normally be reached on 7 to 4 Tuesday-Friday with every other Monday off.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Joseph Hail can be reached on 703 308 2687. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

LEE D. WILSON PRIMARY EXAMINER